

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Conf. No. 5779

Wolfgang STOLZ et al.

Art Unit: 2826

Application No.: 10/580,653

Examiner: Quinto, K.

Filed: March 30, 2007

Attorney Dkt. No.: 12007-0074

For: METHOD FOR PRODUCING OPTICALLY PUMPED SEMICONDUCTOR DEVICES FOR THE GENERATION OF RADIATION AND STRAIN COMPENSATION IN THE LAYER SUCCESSIONS USED WITHIN (AS AMENDED)

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 6, 2010, a petition for a one month extension of time is made. Payment is addressed at the end of this filing. Please revise the application as follows: